

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Confirmation No.: 5700

Katsuhiko Miya, et al.

Date: April 17, 2008

Serial No.: 10/659,213

Group Art Unit: 1792

Filed: September 10, 2003

Examiner: Jason Mark Heckert

For: SUBSTRATE PROCESSING APPARATUS

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**VIA EFS-WEB**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**SUBMISSION**

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I certify that each item of information contained in this Submission was cited in a communication dated February 26, 2008 from a foreign patent office in a counterpart Japanese application not more than 3 months prior to the filing of this Submission.

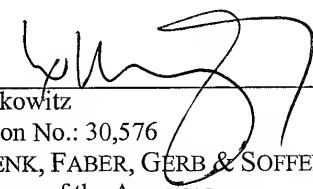
I respectfully request that the information submitted be considered. Credit card payment in the amount of \$180 for the required fee is being submitted via EFS-WEB.

In the event the any actual fee is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the Patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

THIS CORRESPONDENCE IS BEING  
SUBMITTED ELECTRONICALLY  
THROUGH THE PATENT AND  
TRADEMARK OFFICE EFS FILING  
SYSTEM ON April 17, 2008.

MM:ck

Respectfully submitted,

  
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